

In the Claims

This listing of claims will replace all prior versions, and listings, of claims in the application:

Listing of Claims

1. (Previously presented) A method of fabricating a mask, comprising:
 - providing material and device data;
 - defining a first manufacturing model according to the material and the device data;
 - performing a first process run of a first mask as defined by the first manufacturing model;
 - collecting a first process data during the first process run;
 - determining a backward modification data according to the material and the device data, and the first process data;
 - modifying the first manufacturing model according to the backward modification data to obtain a second manufacturing model; and
 - performing a second process run of a second mask as defined by the second manufacturing model.
2. (Original) The method of claim 1, wherein the backward modification data determining step further comprises performing statistical process control analysis.

3. (Original) The method of claim 1, wherein the material data comprises photoresist type, characteristics, production date, post coating decay, or batch relation data.

4. (Original) The method of claim 1, wherein the device data comprises device type, mask layer, mask grade, option correction type, pattern loading or device loading data.

5. (Previously presented) The method of claim 1, wherein the first process data comprises exposure tool, etching chamber, etching time, tooling bias, batch relation, or inspection result data.

6. (Original) The method of claim 1, wherein the manufacturing model defining step further comprises defining a manufacturing model that describes a writing process for masks.

7. (Original) The method of claim 1, wherein the manufacturing model defining step further comprises defining a manufacturing model that describes a baking process for masks.

8. (Original) The method of claim 1, wherein the manufacturing model defining step further comprises defining a manufacturing model that describes a developing process for masks.

9. (Original) The method of claim 1, wherein the manufacturing model defining step further comprises defining a manufacturing model that describes an etching process for masks.

10. (Previously presented) The method of claim 1, further comprising:

acquiring an inspection result of a preceding process run, wherein the inspection result is an after-strip inspection result;

determining a forward modification data according to the first process data and the inspection result;

determining a re-etch manufacturing model according to the forward modification data; and

performing a re-etch process run of the first mask as defined by the re-etch manufacturing model.

11-27. (Canceled)

28. (Original) A computer readable storage medium for storing a computer program providing a method for controlling mask fabrication using statistical process control analysis, the method comprising:

receiving a material, device and first process data of a mask;

defining a first manufacturing model according to the material and the device data;

determining a backward modification data according to the material, the device, and the first process data; and

modifying the first manufacturing model according to the backward modification data to obtain a second manufacturing model; and

issuing a process command, which directs a tool to process a second mask according to the second manufacturing model.

29. (Original) The storage medium of Claim 28, wherein the manufacturing model defining step further comprises defining a manufacturing model that describes a writing process for masks.

30. (Original) The storage medium of Claim 28, wherein the manufacturing model defining step further comprises defining a manufacturing model that describes a baking process for masks.

31. (Original) The storage medium of Claim 28, wherein the manufacturing model defining step further comprises defining a manufacturing model that describes a developing process for masks.

32. (Original) The storage medium of Claim 28, wherein the manufacturing model defining step further comprises defining a manufacturing model that describes an etching process for masks.

33. (Previously presented) The storage medium of Claim 28, wherein the method further comprises:

receiving an inspection result of a preceding process run, wherein the inspection result is an after-strip inspection result;

determining a forward modification data according to the first process data and the inspection result;

determining a re-etch manufacturing model according to the forward modification data; and

issuing a re-etch command, which directs a tool to re-etch the first mask according to the re-etch manufacturing model.

34-38. (Canceled)